L Number	Hits	Search Text	DB	Time stamp		
13	279053	(semi\$1conductor adj pressure adj sensor)	USPAT;	2002/06/04		
••		and gas near2 pressure same flour\$3 near2	US-PGPUB;	13:30		
		elastomer or gel	EPO; JPO	10.00		
23	199	Shinetsu adj Chemical adj Industries	USPAT;	2002/06/04		
23	133	onnetsu auj onemicai auj maustres	US-PGPUB;	13:53		
			EPO; JPO	13.33		
24	454	(Chinatau adi Chamiaal adi Industrias) and	i '	2002/06/04		
	154	(Shinetsu adj Chemical adj Industries) and	USPAT; US-PGPUB;	13:53		
		resin	1	13:33		
			EPO; JPO	2002/06/04		
25	2	pressure adj sensor same polyurethane adj	USPAT;			
		resin	US-PGPUB;	15:52		
			EPO; JPO			
•	58549	pressure adj sensor	USPAT;	2002/06/04		
			US-PGPUB;	14:41		
	_		EPO; JPO			
-	176526	combustion near2 engine	USPAT;	2002/05/31		
			US-PGPUB;	15:34		
			EPO; JPO			
-	8978	(pressure adj sensor) and (combustion	USPAT;	2002/05/31		
		near2 engine)	US-PGPUB;	15:35		
			EPO; JPO			
-	26892	(pressure adj sensor) and (base or housing)	USPAT;	2002/05/31		
			US-PGPUB;	15:37		
			EPO; JPO			
-	4882	((pressure adj sensor) and (base or	USPAT;	2002/05/31		
		housing)) and ((pressure adj sensor) and	US-PGPUB;	15:37		
		(combustion near2 engine))	EPO; JPO			
-	3281	measur\$3 near2 pressure near2 gas	USPAT;	2002/05/31		
			US-PGPUB;	15:40		
			EPO; JPO			
-	20	(measur\$3 near2 pressure near2 gas) and	USPAT;	2002/06/03		
		(pressure adj sensor) and mount\$3 near2	US-PGPUB;	12:45		
		base	EPO; JPO			
_	434	(73/754).CCLS.	USPAT;	2002/05/31		
		(10,10 t),100 201	US-PGPUB;	16:07		
			EPO; JPO			
-	1975	semi\$1conductor adj pressure adj sensor	USPAT;	2002/06/03		
	1373	Semiproonauctor and pressure and semsor	US-PGPUB;	14:31		
			EPO; JPO	1431		
	26	(somitteendusten edi pressure edi concer)	USPAT;	2002/06/03		
•	20	(semi\$1conductor adj pressure adj sensor) and corrosion near2 resistance	US-PGPUB;	12:51		
		and corrosion near2 resistance	1	12:51		
•			EPO; JPO	2002/20/22		
	14	(semi\$1conductor adj pressure adj sensor)	USPAT;	2002/06/03		
		and pressure near2 injection	US-PGPUB;	13:38		
			EPO; JPO			
•	1	(semi\$1conductor adj pressure adj sensor)	USPAT;	2002/06/03		
		and aspiration near2 pressure	US-PGPUB;	14:34		
			EPO; JPO			
-	133	(semi\$1conductor adj pressure adj sensor)	USPAT;	2002/06/03		
		and air near2 pressure	US-PGPUB;	14:39		
			EPO; JPO	1		

Search History 6/4/02 4:09:00 PM Page 1

1					
-	83	(semi\$1conductor adj pressure adj sensor)	USPAT;	2002/06/04	
		and gas near2 pressure	US-PGPUB;	13:29	
		_	EPO; JPO		